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Robust PID based indirect-type iterative learning control for batch processes with time-varying uncertainties

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Abstract: Based on the proportional-integral-derivative (PID) control structure widely used in engineering applications, a robust indirect-type iterative learning control (ILC) method is proposed for industrial batch processes subject to time-varying uncertainties. <u>An important merit</u> is that the proposed ILC design is independent of the PID tuning that aims primarily to hold robust stability of the closed-loop system, owing to the fact that the ILC updating law is implemented through adjusting the setpoint of the closed-loop PID control structure plus a feedforward control to the plant input from batch to batch. According to the robust H infinity control objective, a robust discrete-time PID tuning algorithm is given in terms of the plant state-space model description to accommodate for time-varying process uncertainties. For the batchwise direction, a robust ILC updating law is developed based on the two-dimensional (2D) control system theory. Only measured output errors of current and previous cycles are used to implement the proposed ILC scheme for the convenience of practical application. An illustrative example from the literature is adopted to demonstrate the effectiveness and merits of the proposed ILC method.

Keywords: Batch process, iterative learning control (ILC), proportional-integral-derivative (PID), time-varying uncertainty, robust H infinity control objective

1 Introduction

Iterative learning control (ILC) method can be adopted to realize perfect tracking or control optimization for industrial and chemical batch processes, owing to the use of repetitive operation information from historical cycles. With the wide application of ILC in engineering applications in the recent years, it has become increasingly appealing to develop robust ILC methods to deal with time-varying uncertainties occurring in a cycle or cycle-to-cycle (batchwise) uncertainties, because many batch processes, e.g., industrial injection molding and pharmaceutical crystallization, are slowly varying from batch to batch, while repeating fundamental dynamic response characteristics [1-4]. As surveyed by Bonvin et al [5], Ahn et al [6], and Wang et al [7], most of existing references have been devoted to time-invariant linear or nonlinear batch processes. The developed robust ILC methods have been in general classified into two types [7], one is called direct-type that means the ILC design integrates the feedback control (responsible for closed-loop stability and no steady output deviation) and the feedforward control (responsible for the setpoint tracking) through the identical closed-loop controller, and another is called indirect-type which implies that either the feedback or the feedforward control could be implemented through different controllers that may be designed relatively independent.

For the direct-type ILC, the traditional proportional-integral-derivative (PID) controller including the P-, PI-, PD-, PID-type is mostly used to execute the integrated control for both the setpoint tracking and closed-loop stabilization, owing to its implemental simplicity, e.g. the P-type ILC [8, 9], the PI-type ILC [10, 11], the PD-type ILC [12, 13], the PID-type ILC [14, 15]. The achievable robustness and output tracking performance, however, have not yet been fully explored, in particular for the quantitative performance specifications [16]. Based on a two-dimensional (2D) state-space description of a batch process and using the linear quadratic optimal control criterion in combination with the robust control theory, full-order controller matrices (with respect to the process model order) were used to develop robust direct-type ILC methods to accommodate for a variety of process uncertainties [17-21], but at the expense of controller complexity, computation effort, and memory space for storing the historical information of the cycle and controller state.

For the indirect-type ILC, the control structure is typically composed of two loops, one loop constructed in terms of a conventional controller like PID, and another loop used for adjusting the setpoint or the process input similar to a feedforward control manner. Based on the internal model control (IMC) structure, a learning setpoint design was proposed [22] to robustly track the setpoint profile against the process input delay uncertainty. By comparison, a P-type learning algorithm was presented to adjust the setpoint in combination with the model prediction control (MPC) method for tracking the desired profile, which was successfully used to the control of artificial pancreatic beta-cell [23]. Based on the conventional PID control structure, a parallel learning-type PID was added to improve the setpoint tracking performance without sacrificing the closed-loop stability [24]. An alternative anticipatory-type ILC (A-ILC) was developed to adjust the setpoint in terms of the PID control loop for robust tracking of the desired profile [25]. The robust stability condition of a learning-type setpoint design in terms of a PI control loop was analyzed in the recent paper [26]. A quadratic criterion was presented to analyze the ILC convergence in terms of a MPC structure for time-varying linear systems [27]. The achievable tracking performance of an indirect-type ILC scheme was assessed by estimating the minimum output variance bound [28]. Combining with the feedback control design, a two-step ILC design [29] was proposed to adjust the process input for improving the output tracking performance against load disturbance and process uncertainties. For highly nonlinear processes such as crystallization processes, hierarchical ILC and nonlinear MPC based ILC methods [30, 31] were proposed to track the desired setpoint profile against batch-to-batch uncertainties.

In this paper, an indirect-type ILC design is proposed based on the widely used PID control structure to accommodate for time-varying process uncertainties. With a state-space model description of the process together with norm-bounded uncertainties, a robust PID tuning algorithm is first given in terms of the H infinity control objective, which is primarily responsible for holding the closed-loop system robust stability and no steady output deviation. Then, an ILC scheme consisting of the learning controllers to adjust the setpoint and the feedforward controllers to adjust the process input is proposed to realize robust tracking against time-varying uncertainties and load disturbance, which is therefore different from the conventional

indirect-type ILC scheme. Accordingly, the PID tuning and the ILC design can be made relatively independent of each other in the proposed control scheme, and more flexibility is introduced to devise the control system robust stability and tracking performance, respectively. By establishing the sufficient conditions in terms of linear matrix inequality (LMI) constraints for maintaining robust stability of the PID control loop and the robust convergence of the ILC scheme, respectively, the PID and ILC controllers are derived along with an adjustable robust H infinity performance level. The effectiveness of the proposed method is demonstrated through an illustrative example from the literature. For clarity, the paper is organized as follows: Section 2 briefly describes a batch process with time-varying uncertainties by using a state-space model with norm-bounded uncertainties, and then introduces the proposed indirect-type ILC scheme based on the conventional PID control structure. Correspondingly, a robust PID tuning method is proposed in terms of the robust H infinity control objective in Section 3. By formulating the learning setpoint strategy and feedforward control in the frame of a 2D system, section 4 presents the proposed ILC design by establishing the sufficient LMI conditions to hold the 2D system asymptotic stability. Section 5 shows an illustrative example to demonstrate the effectiveness and merits of the proposed ILC method. Conclusions are drawn in Section 6.

Throughout this paper, the following notations are used: $\Re^{n\times m}$ denotes a $n\times m$ real matrix space. For any matrix $P \in \Re^{m\times m}$, P > 0 (or $P \ge 0$) means P is a positive (or semipositive) definite symmetric matrix, in which the symmetric elements are indicated by '*'. P^{T} denotes the transpose of P. diag{]} denotes a block-diagonal matrix. For any vector x and matrix P > 0, denote $V_{P}(x) = ||x||_{P}^{2} = x^{T}Px$. The identity or zero vector (or matrix) with appropriate dimension is denoted by I or 0. For a 2D signal, z(i, j), if $||z(i, j)||_{2} = \sqrt{\sum_{i=0}^{n} \sum_{j=0}^{m} ||z(i, j)||^{2}} < \infty$ for any integers n and m, then z(i, j) is said to be in the $L_{2}[0, \infty)$ space of all square integrable functions.

2 **Problem formulation**

A batch process with time-varying uncertainties is generally described by the following observable canonical discrete-time state-space model,

$$P_{\Delta}:\begin{cases} x(t+1,k+1) = [A_{m} + \Delta \tilde{A}(t,k+1)]x(t,k+1) + [B_{m} + \Delta \tilde{B}(t,k+1)]u(t,k+1) + \omega(t,k+1) \\ y(t,k+1) = Cx(t,k+1), & 0 \le t \le T_{p}; \\ x(0,k+1) = x(0), & k=0,1,\cdots. \end{cases}$$
(1)

where t and k denotes the time and batch indices, respectively, and k+1 indicates the current batch (or cycle). $x(t,k+1) \in \Re^{n_x}$ denote the state variables, $u(t,k+1) \in \Re^{n_u}$ the control inputs, $y(t,k+1) \in \Re^{n_y}$ the process outputs. Denote by A_m and B_m the nominal state matrices, and by $\Delta \tilde{A}(t,k+1)$ and $\Delta \tilde{B}(t,k+1)$ time-varying uncertainties that are not repetitive from cycle to cycle and practically specified as $\Delta \tilde{A}(t,k+1) = \Delta \bar{A}_i \tilde{\Theta}_1(t) \Delta \bar{A}_2$, $\Delta \tilde{B}(t,k+1) = \Delta \bar{B}_i \tilde{\Theta}_2(t) \Delta \bar{B}_2$, where $\Delta \bar{A}_1$, $\Delta \bar{A}_2$, $\Delta \bar{B}_1$, and $\Delta \bar{B}_2$ are constant matrices, and $\tilde{\Theta}_i^T(t) \tilde{\Theta}_i(t) \leq \mathbf{I}$, i = 1, 2. Denote by T_p the time period of each cycle, and x(0) is the initial resetting condition of each cycle. Note that other process uncertainties such as from input actuator and output measurement may also be lumped into $\Delta \tilde{A}(t,k+1)$ and $\Delta \tilde{B}(t,k+1)$ for analysis.

The control objective is to determine a control law such that the system output can track the desired output profile (or target output trajectory) as close as possible against the process uncertainties and/or load disturbance.

To design an indirect-type ILC scheme, we define the output error in the current cycle (k+1) by

$$e(t, k+1) \square Y_r(t) - y(t, k+1)$$
 (2)

where $Y_r(t)$ denotes the desired output profile, and y(t, k+1) the real output in the current cycle. Correspondingly, the time integral of e(t, k+1) is denoted by $\sum e(t, k+1)$, i.e.

$$\Sigma e(t, k+1) = \sum_{i=0}^{t} e(i, k+1), \quad 0 \le t \le T_p$$
(3)

By comparison, we define the setpoint tracking error in the current cycle by

$$e_{s}(t,k+1) \Box y_{s}(t,k+1) - y(t,k+1)$$
 (4)

where $y_s(t, k+1)$ denotes the setpoint command in the current cycle, which is different with the desired output profile, $Y_r(t)$, in that it is adjusted real-time in an indirect-type ILC scheme for tracking $Y_r(t)$.

The time integral of $e_s(t, k+1)$ is denoted by $\sum e_s(t, k+1)$. It follows that

$$\sum e_{s}(t,k+1) = \sum e_{s}(t-1,k+1) + e_{s}(t,k+1), \quad 0 \le t \le T_{p}$$
(5)

Moreover, we define a batchwise error function by

$$\delta f(t,k+1) \Box f(t,k+1) - f(t,k)$$
(6)

where f may denote x, y_s , u, e, e_s , or ω , respectively.

It follows from (1) using the definitions in (2) and (6) that

$$e(t, k+1) = e(t, k) - C\delta x(t, k+1)$$
 (7)

$$\delta \mathbf{x}(t+1,k+1) = [\mathbf{A}_{m} + \Delta \mathbf{\hat{A}}(t,k+1)] \delta \mathbf{x}(t,k+1) + [\mathbf{B}_{m} + \Delta \mathbf{\hat{B}}(t,k+1)] \delta \mathbf{u}(t,k+1) + \boldsymbol{\varpi}(t,k+1)$$
(8)

where

$$\boldsymbol{\varpi}(\mathbf{t},\mathbf{k}+1) = [\Delta \tilde{\mathbf{A}}(\mathbf{t},\mathbf{k}+1) - \Delta \tilde{\mathbf{A}}(\mathbf{t},\mathbf{k})]\mathbf{x}(\mathbf{t},\mathbf{k}) + [\Delta \tilde{\mathbf{B}}(\mathbf{t},\mathbf{k}+1) - \Delta \tilde{\mathbf{B}}(\mathbf{t},\mathbf{k})]\mathbf{u}(\mathbf{t},\mathbf{k}) + \delta\boldsymbol{\omega}(\mathbf{t},\mathbf{k}+1)$$
(9)

It is obvious that $\varpi(t, k+1) \neq 0$ for any non-repeatable parameter uncertainties and varied initial process conditions from batch to batch, and therefore can be viewed as a non-repeatable load disturbance to deal with.

Based on the conventional PID control structure, the proposed indirect-type ILC scheme is shown in Figure 1, as outlined by the dash-line box, where the learning controllers, L_1 , L_2 , L_3 , are set to adjust the setpoint command, i.e.

$$y_{s}(t,k+1) = y_{s}(t,k) + L_{1}e(t+1,k) + L_{2}\delta e_{s}(t-1,k+1) + L_{3}\delta \sum e_{s}(t-1,k+1)$$
(10)

where $y_s(t,k)$ denotes the setpoint input in the previous cycle, and e(t+1,k) the one-step ahead output error in the previous cycle. It follows from (4), (5), and (6) that

$$\delta e_{s}(t-1,k+1) = e_{s}(t-1,k+1) - e_{s}(t-1,k)$$
(11)

$$\delta \sum \mathbf{e}_{s}(\mathbf{t},\mathbf{k}+1) = \delta \sum \mathbf{e}_{s}(\mathbf{t}-1,\mathbf{k}+1) + \delta \mathbf{e}_{s}(\mathbf{t},\mathbf{k}+1)$$
(12)

It is seen from (10)-(12) that the tracking errors of e(t+1,k), $e_s(t-1,k)$, $e_s(t,k)$, and $\sum e_s(t-1,k)$ in the previous cycle are used to construct the ILC updating law added to the setpoint command in the current cycle, relatively independent of the closed-loop PID control structure shown in Figure 1.

In Figure 1, the feedforward controllers, F_1 , F_2 , F_3 , are used to adjust the process input, i.e.

$$u(t, k+1) = u_{\text{PID}}(t, k+1) + F_1 e_s(t, k+1) + F_2 e_s(t-1, k+1) + F_3 \sum e_s(t-1, k+1)$$
(13)

where u_{PID} is the PID control output. The setpoint tracking errors at the current moment and one-step ahead moment, and the error integral in the current cycle are used to construct the feedforward control in the proposed scheme.

Hence, the proposed ILC scheme (outlined by the dash-line box in Figure 1) and the closed-loop PID control can be designed separately, as detailed in the following two sections.

3 Robust PID tuning

According to the process state-space description in (1), by omitting the batch index for brevity due to its irrelevance to the PID tuning in the proposed control scheme shown in Figure 1, a PID control law is generally expressed in the following form,

$$u_{\text{PID}}(t) = k_{\text{p}}e(t) + k_{\text{i}} \sum e(t) + k_{\text{d}}[e(t+1) - e(t)]$$
(14)

where k_p , k_i , and k_d are the proportional, integral, and derivative parameters of PID, respectively. Note that because e(t+1) cannot be measured at the current moment for implementing u(t), the differential signal of e(t+1)-e(t) is practically substituted by e(t)-e(t-1), [e(t)+e(t-2)-2e(t-1)]/2, or adding a low-pass filter for execution but at the expense of somewhat performance degradation [32].

By introducing an auxiliary state variable, $\sum e(t)$, we establish the augmented control system description,

$$\begin{cases} \begin{bmatrix} \mathbf{x}(t+1) \\ \Sigma \mathbf{e}(t) \end{bmatrix} = \left(\begin{bmatrix} \tilde{\mathbf{A}} & \mathbf{0} \\ -\mathbf{C} & \mathbf{I} \end{bmatrix} \begin{bmatrix} \mathbf{x}(t) \\ \Sigma \mathbf{e}(t-1) \end{bmatrix} + \begin{bmatrix} \tilde{\mathbf{B}} \\ \mathbf{0} \end{bmatrix} \mathbf{u}(t) + \begin{bmatrix} \mathbf{I} \\ \mathbf{0} \end{bmatrix} \boldsymbol{\omega}(t) \\ \mathbf{y}(t) = \begin{bmatrix} \mathbf{C} & \mathbf{0} \end{bmatrix} \begin{bmatrix} \mathbf{x}(t) \\ \Sigma \mathbf{e}(t-1) \end{bmatrix}$$
(15)

where $\tilde{A} = A_m + \Delta \tilde{A}(t)$ and $\tilde{B} = B_m + \Delta \tilde{B}(t)$.

Substituting (2) with $Y_r(t) = 0$ (which has no influence to the closed-loop stability) into (14) in terms of the nominal process model described by (1) (i.e. $\Delta \tilde{A}(t) = 0$ and $\Delta \tilde{B}(t) = 0$) yields,

$$u_{\text{PID}}(t) = (\mathbf{I} + k_{\text{d}}CB_{\text{m}})^{-1}(k_{\text{p}} + k_{\text{i}})e(t) + (\mathbf{I} + k_{\text{d}}CB_{\text{m}})^{-1}k_{\text{i}}\sum e(t-1) + (\mathbf{I} + k_{\text{d}}CB_{\text{m}})^{-1}k_{\text{d}}(C\mathbf{I} - A_{\text{m}})x(t)$$
(16)

Let

$$\hat{k}_{p} = (\mathbf{I} + k_{d}CB_{m})^{-1}(k_{p} + k_{i})$$
 (17)

$$\hat{\mathbf{k}}_{i} = (\mathbf{I} + \mathbf{k}_{d} \mathbf{C} \mathbf{B}_{m})^{-1} \mathbf{k}_{i}$$
(18)

$$\hat{\mathbf{k}}_{\mathrm{d}} = (\mathbf{I} + \mathbf{k}_{\mathrm{d}} \mathbf{C} \mathbf{B}_{\mathrm{m}})^{-1} \mathbf{k}_{\mathrm{d}}$$
(19)

Then, substituting (14) and (17)-(19) into (15) yields the closed-loop system,

$$\begin{cases} \begin{bmatrix} \mathbf{x}(t+1) \\ \Sigma \mathbf{e}(t) \end{bmatrix} = \begin{bmatrix} \tilde{\mathbf{A}} + \tilde{\mathbf{B}}[\hat{\mathbf{k}}_{d}(\mathbf{C}\mathbf{I} - \mathbf{A}_{m}) - \hat{\mathbf{k}}_{p}\mathbf{C}] & \tilde{\mathbf{B}}\hat{\mathbf{k}}_{i} \\ -\mathbf{C} & \mathbf{I} \end{bmatrix} \begin{bmatrix} \mathbf{x}(t) \\ \Sigma \mathbf{e}(t-1) \end{bmatrix} + \begin{bmatrix} \mathbf{I} \\ \mathbf{0} \end{bmatrix} \boldsymbol{\omega}(t) \\ y(t) = \begin{bmatrix} \mathbf{C} & \mathbf{0} \end{bmatrix} \begin{bmatrix} \mathbf{x}(t) \\ \Sigma \mathbf{e}(t-1) \end{bmatrix}$$
(20)

For tuning the PID controller to maintain the control system robust stability, the H infinity control objective is adopted here, i.e.

$$\left\| \mathbf{e}(\mathbf{t}) \right\|_{2} < \gamma_{\text{PID}} \left\| \boldsymbol{\omega}(\mathbf{t}) \right\|_{2} \tag{21}$$

where $\gamma_{\rm PID}$ denotes the robust performance level.

To achieve the H infinity control objective, we give the following theorem,

Theorem 1: The PID control system in (20) subject to time-varying process uncertainties shown in (1) is guaranteed robustly stable with a H infinity control performance level, γ_{PID} , if there exist $P_{11} > 0$, $P_{22} > 0$, matrices P_{12} , R_1 , R_2 , and positive scalars ε_1 , ε_2 , such that the following LMI holds,

$$\begin{bmatrix} -P + \varepsilon_{1} \Phi_{A1} \Phi_{A1}^{T} + \varepsilon_{2} \Phi_{B1} \Phi_{B1}^{T} & \Gamma & D_{g} & \mathbf{0} & \mathbf{0} & \mathbf{0} \\ * & -P & \mathbf{0} & PH^{T}C^{T} & P\Phi_{A2}^{T} & P\Phi_{B2}^{T} \\ * & * & -\gamma_{PID}\mathbf{I} & \mathbf{0} & \mathbf{0} & \mathbf{0} \\ * & * & * & -\gamma_{PID}\mathbf{I} & \mathbf{0} & \mathbf{0} \\ * & * & * & * & -\varepsilon_{1}\mathbf{I} & \mathbf{0} \\ * & * & * & * & * & -\varepsilon_{2}\mathbf{I} \end{bmatrix} < 0$$
(22)

where $\mathbf{D}_{g} = [\mathbf{I} \quad \mathbf{0}]^{\mathrm{T}}$, $\mathbf{H} = [\mathbf{I} \quad \mathbf{0}]$, $\Phi_{A1} = [\Delta \overline{A}_{1}^{\mathrm{T}}, \mathbf{0}]^{\mathrm{T}}$, $\Phi_{A2} = [\Delta \overline{A}_{2}P_{11}, \Delta \overline{A}_{2}P_{12}]$, $\Phi_{B1} = [\Delta \overline{B}_{1}^{\mathrm{T}}, \mathbf{0}]^{\mathrm{T}}$, $\Phi_{B2} = [\Delta \overline{B}_{2}P_{1}, \Delta \overline{B}_{2}P_{2}]$,

$$\mathbf{P} = \begin{bmatrix} \mathbf{P}_{11} & \mathbf{P}_{12} \\ * & \mathbf{P}_{22} \end{bmatrix}, \quad \boldsymbol{\Gamma} = \begin{bmatrix} \mathbf{A}_{m} \mathbf{P}_{11} + \mathbf{B}_{m} \mathbf{R}_{1} & \mathbf{A}_{m} \mathbf{P}_{12} + \mathbf{B}_{m} \mathbf{R}_{2} \\ -\mathbf{C} \mathbf{P}_{11} + \mathbf{P}_{12}^{\mathrm{T}} & -\mathbf{C} \mathbf{P}_{12} + \mathbf{P}_{22} \end{bmatrix}$$

by parameterizing

$$[\hat{k}_{d}(C\mathbf{I} - A_{m}) - \hat{k}_{p}C \quad \hat{k}_{i}] = [R_{1} \quad R_{2}]P^{-1}$$
 (23)

Proof: See the Appendix I.

It can be seen from (17)-(19) and (23) that the PID parameters may be retrieved by prescribing the derivative parameter(s), k_d , that is, when k_d is specified, the other parameters can be obtained using (19) as

$$\mathbf{k}_{i} = \hat{\mathbf{k}}_{i} \left(\mathbf{I} + \mathbf{k}_{d} \mathbf{C} \mathbf{B}_{m} \right) \tag{24}$$

$$\mathbf{k}_{\mathrm{p}} = \hat{\mathbf{k}}_{\mathrm{p}} (\mathbf{I} + \mathbf{k}_{\mathrm{d}} \mathbf{C} \mathbf{B}_{\mathrm{m}}) - \mathbf{k}_{\mathrm{i}}$$
(25)

Note that letting $k_d = 0$ leads to a PI controller, which is preferred for practical application owing to the implemental simplicity.

To achieve good robust control performance, the PI (by letting $k_d = 0$) or PID controller can be determined by performing the following optimization program,

$$\underset{\Delta \tilde{A}(t), \Delta \tilde{B}(t)}{\text{Minimize}} \gamma_{\text{PID}}$$
(26)

In fact, a smaller value of γ_{PID} leads to a more aggressive control action and vice versa. Therefore, a trade-off should be made between the achievable control performance and the control action generated by the designed PI or PID controller. In consideration of that the closed-loop controller is primarily used for maintaining the control system robust stability, it is preferred to take a PI controller for implementation if such a controller can be derived from the above optimization program, compared to a PID controller which requires a practical implementation of the ideal derivative action that may degrade the closed-loop robust stability or control performance.

4 Robust indirect-type ILC design

To develop a robust indirect-type ILC method, a 2D system model is constructed to describe the process dynamics along both the time and batchwise directions, for the purpose of synthetically analyzing the 2D stability against process uncertainties and load disturbance. A preliminary knowledge of a 2D system stability is presented as below.

Consider a 2D Roesser's system [33],

$$\begin{cases} \begin{bmatrix} x^{h}(i+1,j) \\ x^{v}(i,j+1) \end{bmatrix} = \begin{bmatrix} A_{11} + \Delta A_{11} & A_{12} + \Delta A_{12} \\ A_{21} + \Delta A_{21} & A_{22} + \Delta A_{22} \end{bmatrix} \begin{bmatrix} x^{h}(i,j) \\ x^{v}(i,j) \end{bmatrix} + \omega(i,j)$$

$$y(i,j) = \begin{bmatrix} C_{1} & C_{2} \end{bmatrix} \begin{bmatrix} x^{h}(i,j) \\ x^{v}(i,j) \end{bmatrix}$$

$$i, j=0,1,2,\cdots.$$
(27)

where $x^{h} \in \Re^{n_{1}}$ is the horizontal state vector, $x^{v} \in \Re^{n_{2}}$ the vertical state vector, y the system output, ω load disturbance, ΔA_{11} , ΔA_{12} , ΔA_{21} , and ΔA_{22} denote the state matrices uncertainties. The boundary condition of the Roesser's system is denoted by $\hat{x}(t) = \left[[x^{h}(0, j)]^{T}, [x^{v}(i, 0)]^{T} \right]^{T}$.

Lemma 1 [26]: If there exist positive definite matrices, $P_1 > 0$ and $P_2 > 0$, such that the following LMI holds

$$\tilde{A}^{T}P\tilde{A} - P < 0 \tag{28}$$

where

$$\tilde{A} = \begin{bmatrix} A_{11} + \Delta A_{11} & A_{12} + \Delta A_{12} \\ A_{21} + \Delta A_{21} & A_{22} + \Delta A_{22} \end{bmatrix}, P = diag\{P_1, P_2\}$$

then the 2D Roesser's system in (27) with $\omega = 0$ is asymptotically stable. In addition, if $x^{h}(0, j) \equiv 0$, there exists a positive scalar $\rho \in (0, 1)$ such that

$$\sum_{i=0}^{I_0} V_{P_2}[x^{v}(i, j+1)] < \rho \sum_{i=0}^{I_0} V_{P_2}[x^{v}(i, j)], \quad \forall j > 0, \ \forall I_0 > 0 \ , \ \forall x^{v}(i, 0).$$
(29)

According to the proposed ILC scheme shown in Figure 1, $\underline{it \text{ follows from (4), (6), and (7)}}$ that

$$y_{s}(t,k+1) - y_{s}(t,k) = \delta e_{s}(t,k+1) + C \delta x(t,k+1)$$
 (30)

Substituting (30) into (10) yields

$$\delta e_{s}(t,k+1) = L_{1}e(t+1,k) + L_{2}\delta e_{s}(t-1,k+1) + L_{3}\delta \sum e_{s}(t-1,k+1) - C\delta x(t,k+1)$$
(31)

Then, substituting (31) into (12) obtains

$$\delta \sum e_{s}(t,k+1) = L_{1}e(t+1,k) + L_{2}\delta e_{s}(t-1,k+1) + (\mathbf{I}+L_{3})\delta \sum e_{s}(t-1,k+1) - C\delta x(t,k+1)$$
(32)

Substituting the PID control law of (14) with e(t+1)-e(t) replaced by e(t)-e(t-1) into (13), we obtain

$$u(t, k+1) = k_{p}e_{s}(t, k+1) + k_{i} \sum e_{s}(t, k+1) + k_{d}[e_{s}(t, k+1) - e_{s}(t-1, k+1)] +F_{1}e_{s}(t, k+1) + F_{2}e_{s}(t-1, k+1) + F_{3} \sum e_{s}(t-1, k+1) = (k_{p} + k_{i} + k_{d} + F_{1})e_{s}(t, k+1) + (F_{2} - k_{d})e_{s}(t-1, k+1) + (k_{i} + F_{3}) \sum e_{s}(t-1, k+1)$$
(33)

Note that the ideal derivative term in (14) is substituted by a practical form of e(t)-e(t-1) for obtaining (33). Other practical forms may also be adopted to derive u(t, k+1) and are omitted herein.

Correspondingly, it follows that

$$\delta u(t,k+1) = (k_p + k_i + k_d + F_1) \delta e_s(t,k+1) + (F_2 - k_d) \delta e_s(t-1,k+1) + (k_i + F_3) \delta \sum e_s(t-1,k+1)$$
(34)

Based on the robust PID design given in Section 2, by substituting (31), (32), and (34) into (8), we obtain

$$\delta \mathbf{x}(\mathbf{t}+1\mathbf{k}+1) = \tilde{\mathbf{A}} \begin{bmatrix} \tilde{\mathbf{B}} \mathbf{k}_{p} (\mathbf{t} \mathbf{k}_{i}+\mathbf{k}_{d}+\mathbf{F} \mathbf{C} \ \delta \mathbf{x} \mathbf{l} \mathbf{k} \mathbf{t}, 1) \\ + \tilde{\mathbf{B}}(\mathbf{k}_{p}+\mathbf{k}_{i}+\mathbf{k}_{d}+\mathbf{F}) \mathbf{L} \mathbf{e}(\mathbf{t}+1,\mathbf{k}) \\ + \tilde{\mathbf{B}}[(\mathbf{k}_{p}+\mathbf{k}_{i}+\mathbf{k}_{d}+\mathbf{F})\mathbf{L} + \mathbf{k}_{2}\mathbf{F} - \mathbf{k}] \delta \mathbf{g} (\mathbf{t} - \mathbf{k}\mathbf{k} + 1) \\ + \tilde{\mathbf{B}}[(\mathbf{k}_{p}+\mathbf{k}_{i}+\mathbf{k}_{d}+\mathbf{F})\mathbf{L} + \mathbf{k}_{3} + \mathbf{k}_{3}] \delta \mathbf{g} (\mathbf{t} - \mathbf{k}\mathbf{k} + 1) \\ + \sigma(\mathbf{t},\mathbf{k}+1)$$
(35)

where $\tilde{A} = A_m + \Delta \tilde{A}(t, k+1)$ and $\tilde{B} = B_m + \Delta \tilde{B}(t, k+1)$.

$$\begin{array}{l} \underline{Consequently, the predicted output error can be derived in terms of (7)}_{eff} as \\ e(t+1,k+1) &= e(t+1)k - \delta C \quad x \notin 1 \# 1) \\ &= -C \tilde{A} + \tilde{C}[B_{p}k + _{i}k + (_{d}k + _{1}F \delta C \quad x)t + k \quad (, \\ &+ I - C \tilde{B} \quad k + [k + k (+ F \quad L \quad e \quad t \quad)k \quad] \quad (1) \\ &- C \tilde{B} \quad k + [k + k (+ F \quad L \quad e \quad t \quad)k \quad] \quad (1) \\ &- C \tilde{B}[(k_{p} + k_{i} + k \quad d \quad F \quad]L \quad +_{3}F \quad +_{3}k \quad]\delta \sum e(t - _{s}1, k + 1) \\ &- C \varpi(t, k + 1) \end{array}$$

$$(36)$$

Therefore, a 2D system description of the proposed ILC scheme can be formulated by

$$\begin{cases} \delta x(t+1,k+1) \\ \delta e_{s}(t,k+1) \\ \delta \sum e_{s}(t,k+1) \\ e(t+1,k+1) \end{cases} = \tilde{\Psi} \begin{bmatrix} \delta x(t,k+1) \\ \delta e_{s}(t-1,k+1) \\ \delta \sum e_{s}(t-1,k+1) \\ e(t+1,k) \end{bmatrix} + D_{w} \boldsymbol{\varpi}(t)$$

$$\begin{cases} \delta x(t,k+1) \\ e(t+1,k) \\ \delta e_{s}(t-1,k+1) \\ \delta \sum e_{s}(t-1,k+1) \\ \delta \sum e_{s}(t-1,k+1) \\ e(t+1,k) \end{bmatrix}$$

$$(37)$$

where $G = [0 \ 0 \ 0 \ I], D_w = [I \ 0 \ 0 \ -C^T]^T$,

$$\begin{split} \tilde{\Psi} = \begin{bmatrix} \tilde{A} - \tilde{B}(k_{p} + k_{i} + k_{d} + F_{1})C & \tilde{B}[(k_{p} + k_{i} + k_{d} + F_{1})L_{2} + F_{2} - k_{d}] \\ -C & L_{2} \\ -C & L_{2} \\ -C\tilde{A} + C\tilde{B}(k_{p} + k_{i} + k_{d} + F_{1})C & -C\tilde{B}[(k_{p} + k_{i} + k_{d} + F_{1})L_{2} + F_{2} - k_{d}] \\ \tilde{B}[(k_{p} + k_{i} + k_{d} + F_{1})L_{3} + F_{3} + k_{i}] & \tilde{B}(k_{p} + k_{i} + k_{d} + F_{1})L_{1} \\ L_{3} & L_{1} \\ I + L_{3} & L_{1} \\ -C\tilde{B}[(k_{p} + k_{i} + k_{d} + F_{1})L_{3} + F_{3} + k_{i}] & I - C\tilde{B}(k_{p} + k_{i} + k_{d} + F_{1})L_{1} \end{bmatrix} \end{split}$$

<u>Note that</u> $\zeta(t, k+1) = e(t+1, k)$ <u>can be regarded as the controlled variable to be minimized</u> <u>against process uncertainties, possibly varied initial process conditions from batch to batch, and</u> <u>load disturbance</u>. That is to say, the robust 2D control objective can be determined in terms of a batch process control specification [21] as

$$\mathbf{J}_{\rm BP} = \sum_{t=0}^{N_1 = T_p} \sum_{k=0}^{N_2 \to \infty} (\gamma_{\rm ILC}^{-1} \| \boldsymbol{\zeta}(t, k+1) \|_2^2 - \gamma_{\rm ILC} \| \boldsymbol{\varpi}(t, k+1) \|_2^2) < 0$$
(38)

By defining

$$\mathbf{x}^{\mathrm{h}}(\mathbf{t},\mathbf{k}) = \begin{bmatrix} \delta \mathbf{x}(\mathbf{t},\mathbf{k}+1) \\ \delta \mathbf{e}_{\mathrm{s}}(\mathbf{t}-1,\mathbf{k}+1) \\ \delta \sum \mathbf{e}_{\mathrm{s}}(\mathbf{t}-1,\mathbf{k}+1) \end{bmatrix}, \quad \mathbf{x}^{\mathrm{v}}(\mathbf{t},\mathbf{k}) = \mathbf{e}(\mathbf{t}+1,\mathbf{k})$$
(39)

the 2D system in (37) can be viewed as a typical Roesser's system in the form of (27).

Hence, analyzing the robust stability of the proposed ILC scheme is equivalent to that of the 2D system in (37). The following theorem is given to assess the robust stability and determine the ILC controllers:

Theorem 2: The 2D control system in (37) subject to time-varying process uncertainties described by (1) is guaranteed robustly stable with a H infinity control performance level, γ_{ILC} , if there exist $Q_1 > 0$, $Q_2 > 0$, $Q_3 > 0$, $Q_4 > 0$, matrices \hat{F}_2 , \hat{F}_3 , \hat{L}_1 , \hat{L}_2 , \hat{L}_3 , and positive scalars ε_1 , ε_2 , such that the following LMI holds,

$$\begin{bmatrix} -\mathbf{Q} + \varepsilon_{1}\Omega_{A1}\Omega_{A1}^{T} + \varepsilon_{2}\Omega_{B1}\Omega_{B1}^{T} & \Pi & \mathbf{D}_{w} & \mathbf{0} & \mathbf{0} & \mathbf{0} \\ & * & -\mathbf{Q} & \mathbf{0} & \mathbf{Q}\mathbf{G}^{T} & \mathbf{P}\Omega_{A2}^{T} & \mathbf{P}\Omega_{B2}^{T} \\ & * & * & -\gamma_{\Pi C}\mathbf{I} & \mathbf{0} & \mathbf{0} \\ & * & * & * & -\gamma_{\Pi C}\mathbf{I} & \mathbf{0} & \mathbf{0} \\ & * & * & * & * & -\varepsilon_{1}\mathbf{I} & \mathbf{0} \\ & * & * & * & * & * & -\varepsilon_{2}\mathbf{I} \end{bmatrix} < \mathbf{0}$$
(40)

where $\mathbf{Q} = \text{diag}\{\mathbf{Q}_1, \, \mathbf{Q}_2, \, \mathbf{Q}_3, \, \mathbf{Q}_4\}, \, \mathbf{D}_g = [\mathbf{I} \quad \mathbf{0}]^{\mathrm{T}}, \quad \mathbf{H} = [\mathbf{I} \quad \mathbf{0}], \quad \boldsymbol{\Omega}_{\mathrm{A1}} = [\Delta \overline{\mathbf{A}}_{\mathrm{T}}^{\mathrm{T}}, \, \mathbf{0}, \, \mathbf{0}, \, -\Delta \overline{\mathbf{A}}_{\mathrm{T}}^{\mathrm{T}}\mathbf{C}^{\mathrm{T}}]^{\mathrm{T}},$ $\boldsymbol{\Omega}_{\mathrm{A2}} = [\Delta \overline{\mathbf{A}}_2, \, \mathbf{0}, \, \mathbf{0}, \, \mathbf{0}, \, \boldsymbol{\Omega}_{\mathrm{B1}} = [\Delta \overline{\mathbf{B}}_1^{\mathrm{T}}, \, \mathbf{0}, \, \mathbf{0}, \, -\Delta \overline{\mathbf{B}}_1^{\mathrm{T}}\mathbf{C}^{\mathrm{T}}]^{\mathrm{T}},$

$$\begin{split} \Omega_{B2} = & \left[-\Delta \bar{B}_{2}(k_{p} + k_{i} + k_{d} + F_{1})C, \ \Delta \bar{B}_{2}[(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{2} + \hat{F}_{2} - k_{d}], \\ \Delta \bar{B}_{2}[(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{3} + \hat{F}_{3} + k_{i}], \ \Delta \bar{B}_{2}(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{1} \right] \\ \Pi = & \begin{bmatrix} A_{m}Q_{l} - B_{m}(k_{p} + k_{i} + k_{d} + F_{1})CQ_{l} & B_{m}(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{2} + B_{m}\hat{F}_{2} - B_{m}k_{d}Q_{2} \\ -CQ_{l} & \hat{L}_{2} \\ -CQ_{l} & \hat{L}_{2} \\ -CA_{m}Q_{l} + CB_{m}(k_{p} + k_{i} + k_{d} + F_{1})CQ_{l} & -CB_{m}(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{2} - CB_{m}\hat{F}_{2} + CB_{m}k_{d}Q_{2} \\ & B_{m}(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{3} + B_{m}\hat{F}_{3} + B_{m}k_{i}Q_{3} & B_{m}(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{1} \\ & \hat{L}_{3} & \hat{L}_{1} \\ & Q_{3} + \hat{L}_{3} & \hat{L}_{1} \\ -CB_{m}(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{3} - CB_{m}\hat{F}_{3} - CB_{m}k_{i}Q_{3} & Q_{4} - CB_{m}(k_{p} + k_{i} + k_{d} + F_{1})\hat{L}_{1} \end{bmatrix} \end{split}$$
(41)

by parameterizing

$$\begin{cases} L_{1} = \hat{L}_{1}Q_{4}^{-1} \\ L_{2} = \hat{L}_{2}Q_{2}^{-1} \\ L_{3} = \hat{L}_{3}Q_{3}^{-1} \end{cases}$$
(42)

$$\begin{cases} F_2 = \hat{F}_2 Q_2^{-1} \\ F_3 = \hat{F}_3 Q_3^{-1} \end{cases}$$
(43)

Proof: See the Appendix II.

Note that the feedforward controller, F_1 , is prescribed for solving the LMI condition in (40). To facilitate the feasibility of the LMI condition in (40), the choice of F_1 should be made to keep all the eigenvalues of $A_m - B_m(k_p + k_i + k_d + F_1)C$ in the unit circle in the z-transfer plane, i.e.

$$\left|\lambda_{i}\right| = \left|eig[A_{n} - B_{m}(k_{p} + k_{i} + k_{d} + F_{1})C]\right| < 1, \quad i = 1, 2, \dots, n_{x}.$$
(44)

In fact, all the feedforward controllers, F_1 , F_2 , F_3 , corresponding to F_1 , \hat{F}_2 , \hat{F}_3 in (40) that may be viewed as slack variables to facilitate the LMI feasibility, are used to increase the flexibility of the indirect-type ILC in the proposed control scheme shown in Figure 1, for the purpose of robustly tracking the desired output profile against process uncertainties and load disturbance.

To obtain the optimal robust tracking performance, the ILC controllers can be determined by performing the following optimization program,

$$\underset{\Delta \tilde{A}(t), \Delta \tilde{B}(t)}{\text{Minimize}} \gamma_{\text{ILC}}$$

$$\tag{45}$$

Similarly, by specifying the learning controllers, L_1 , L_2 , L_3 , which determine the convergence rate of the ILC scheme, the achievable robust performance can be assessed through the LMI condition in (40), and so is for the allowable process uncertainty bounds denoted by $\Delta \tilde{A}(t, k+1)$ and $\Delta \tilde{B}(t, k+1)$. Note that the allowable variation of initial process conditions from batch to batch can also be assessed through the LMI condition in (40) by lumping the variation bound into the magnitude (D_w) of the disturbance as shown in (9) and (37).

5 Illustration

Consider a typical batch process, injection molding, as studied in the references [10, 26], which consists of three main stages: filling, packing/holding, and cooling. For the packing stage, a key process variable to be controlled is the nozzle pressure, which should follow a desired profile to preserve product quality. During the cyclic operation, the transition from filling to packing may cause uncertain initial value of the nozzle pressure and perturbation in the load, which hinders the conventional direct-type ILC such as a P-type from reliable application. In contrast, the conventional PID control structure cannot improve the control performance from cycle to cycle. Based on open-loop tests and analysis, a model of the nozzle pressure response to the hydraulic valve input signal was identified [10] as

$$P_{\Delta}(z^{-1}): \quad y(t,k+1) = \frac{1.239(\pm 5\%)z^{-1} - 0.9282(\pm 5\%)z^{-2}}{1 - 1.607(\pm 5\%)z^{-1} + 0.6086(\pm 5\%)z^{-2}}u(t,k+1) + \omega(t,k+1)$$

where the percentages in parentheses indicate the parameter perturbations in the worst case of cyclic operation.

For application of the proposed method, we write the above model in the following state-space form,

$$P_{\Delta} : \begin{cases} x(t+1,k+1) = \begin{pmatrix} 1.607 & 1 \\ -0.6086 & 0 \end{bmatrix} + \Delta \tilde{A} \\ x(t,k+1) + \begin{pmatrix} 1.239 \\ -0.9282 \end{bmatrix} + \Delta \tilde{B} \\ u(t,k+1) + \begin{bmatrix} 1 \\ 0 \end{bmatrix} \\ \omega(t,k+1) \\ \omega(t,k+1) = \begin{bmatrix} 1, & 0 \end{bmatrix} \\ x(t,k+1) \\ \Delta \tilde{A}(t) = \begin{bmatrix} 0.0804 \\ -0.0304 \\ \delta(t) & 0 \end{bmatrix} = \begin{bmatrix} 1 & 0 \\ 0 & 1 \end{bmatrix} \begin{bmatrix} \delta(t) & 0 \\ 0 & \delta(t) \end{bmatrix} \begin{bmatrix} 0.0804 & 0 \\ -0.0304 & 0 \end{bmatrix} \\ \Delta \tilde{B}(t) = \begin{bmatrix} 0.062 \\ -0.0464 \\ \delta(t) \end{bmatrix} = \begin{bmatrix} 1 & 0 \\ 0 & 1 \end{bmatrix} \begin{bmatrix} \delta(t) & 0 \\ 0 & \delta(t) \end{bmatrix} \begin{bmatrix} 0.062 \\ -0.0464 \end{bmatrix}$$

where $\delta(t)$ is a time-varying factor along either the time or batchwise direction and $|\delta(t)| \le 1$.

By performing the optimization procedure in (26), we obtain the minimal H infinity robust performance level, $\gamma_{PID}^* = 1.28$. To avoid over aggressive control signal, we take $\gamma_{PID} = 5$ to solve the LMI condition in (22), obtaining the PI controller parameters, $k_p = 1.2889$ and $k_i = 0.0336$. For the ILC design, it can be easily verified that the range of $F_1 \in [-1.3, 0.1]$ can ensure all the eigenvalues of $A_m - B_m(k_p + k_i + k_d + F_1)C$ located in the unit circle in the z-transfer plane. We choose $F_1 = -0.5$ to perform the optimization procedure in (40), obtaining the minimal H infinity robust performance level, $\gamma_{ILC}^* = 110$, and correspondingly, $L_1 = 0.1776$, $L_2 = 0$, $L_3 = -0.029$, $F_2 = 0$, and $F_3 = -0.0097$.

The target profile (Y_r) takes the following form as adopted in the cited references [10, 26],

$$Y_{r} = \begin{cases} 200, & 0 \le t \le 100; \\ 200+5(t-100), & 100 < t \le 120; \\ 300, & 120 < t \le T_{p} = 200 \end{cases}$$

For illustration, the following cases of process uncertainties are tested.

Case 1. Time-invariant process uncertainties. In this case, $\Delta \tilde{A}(t)$ and $\Delta \tilde{B}(t)$ are assumed to be fixed as their upper bounds. The tracking results are shown in Figure 2 (a) and (b), while the output tracking error in terms of the following criterion is plotted in Figure 3,

$$ATE(k) = \sum_{t=1}^{T_p} \left| e(t,k) \right| / T_p$$

It is seen that perfect tracking is reached through 20 cycles by the proposed method after an initial run of the PID tuning, compared to the cited paper [26] which needed almost 50 cycles to realize perfect tracking. Moreover, there exists no steady output tracking error in each cycle, owing to using the output tracking error in the current cycle for 2D ILC design as shown in (37).

Case 2. Time-varying uncertainties and disturbance. Assume that the process state transfer matrices becomes time-varying with $|\delta(t)| \le 0.1$, together with non-repetitive load disturbance, $\omega(t, k+1) = \sin(t+\theta(k))$ where $\theta(k)$ is a random variable uniformly distributed in the range of $[0, 2\pi]$ as assumed in the cited paper [26]. Since the closed-loop system becomes a stochastic process, we perform 100 Monte Carlo tests, each of which includes 100 cycles. The averaged results of ATE are plotted in Figure 4, in comparison with those of refs. [10, 26]. It is seen that the closed-loop system maintains robust stability well in both the time and batchwise directions by the proposed ILC method, thus demonstrating that it can be reliably used for robust tracking of the desired profile and on-line optimization against batch-to-batch process uncertainties and load disturbance.

6 Conclusions

For industrial batch processes subject to time-varying uncertainties from batch to batch, a robust indirect-type ILC method has been proposed based on the conventional PID control structure. In the proposed control scheme, either the closed-loop PID controller or the ILC updating law can be designed relatively independent, <u>along with the feedforward controllers</u> <u>added to increase the control flexibility</u>, which is therefore different from the standard <u>indirect-type ILC structure studied in the literature</u>. To accommodate for the time-varying uncertainties, a robust PID design has been given based on the robust H infinity control objective. For implemental simplicity, it is preferred to use a PI controller if such a controller can be derived

from the LMI conditions established for maintaining the closed-loop robust stability. For the batchwise direction, an ILC scheme consisting of a learning setpoint strategy and a feedforward control added to the process input has been developed based on an equivalent 2D system description of the batch process and the LMI condition formulated in terms of the robust H infinity control objective for robust convergence. Only measured output errors of current and previous cycles are used to implement the proposed ILC scheme for the convenience of practical application. The application to an illustrative example from the literature has demonstrated the effectiveness and merits of the proposed ILC method.

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Appendix I

Proof of Theorem 1

Define the following Lyapunov-Krasovskii inequality of state energy to guarantee the asymptotic stability of the closed-loop system shown in (20),

$$V_{\rm P}[\hat{\mathbf{x}}(t+1)] - V_{\rm P}[\hat{\mathbf{x}}(t)] < -(\gamma_{\rm PID}^{-1} \| \mathbf{e}(t) \|_{2}^{2} - \gamma_{\rm PID} \| \boldsymbol{\omega}(t) \|_{2}^{2})$$
(A1)

where $\hat{\mathbf{x}}(t) = [\mathbf{x}^{\mathrm{T}}(t), \ \sum \mathbf{e}(t-1)^{\mathrm{T}}]^{\mathrm{T}}$, and γ_{PID} is the robust performance level as shown in (21).

Considering that e(t) = -Cx(t) by letting $Y_r(t) = 0$, and $x(t) = [\mathbf{I}, \mathbf{0}]\hat{x}(t)$, we have

$$\mathbf{e}(\mathbf{t}) = -\mathbf{C}\mathbf{H}\hat{\mathbf{x}}(\mathbf{t}) \tag{A2}$$

where H has been shown in (22).

By substituting (20) into (A1), we obtain

$$\zeta^{T} \Xi_{1} \zeta < 0 \tag{A3}$$

where $\zeta = [\hat{\mathbf{x}}^{\mathrm{T}}(t), \boldsymbol{\omega}^{\mathrm{T}}(t)]^{\mathrm{T}}, \mathbf{D}_{\mathrm{g}} = [\mathbf{I} \quad 0]^{\mathrm{T}}$, and

$$\tilde{A}_{g} = \begin{bmatrix} \tilde{A} + \tilde{B}[\hat{k}_{d}(C\mathbf{I} - A_{m}) - \hat{k}_{p}C] & \tilde{B}\hat{k}_{i} \\ -C & \mathbf{I} \end{bmatrix}$$
(A4)

$$\Xi_{1} = \begin{bmatrix} \tilde{A}_{g}^{T} \\ D_{g}^{T} \end{bmatrix} P \begin{bmatrix} \tilde{A}_{g} & D_{g} \end{bmatrix} - \begin{bmatrix} P - \gamma_{PID}^{-1} H^{T} C^{T} C H & \mathbf{0} \\ * & \gamma_{PID} \mathbf{I} \end{bmatrix}$$
(A5)

By the Schur complement, it can be derived that (A3) is guaranteed by

$$\begin{bmatrix} -\mathbf{P} \quad \tilde{\Gamma} \quad \mathbf{D}_{g} \quad \mathbf{0} \\ * \quad -\mathbf{P} \quad \mathbf{0} \quad \mathbf{PH}^{\mathrm{T}}\mathbf{C}^{\mathrm{T}} \\ * \quad * \quad -\gamma_{\mathrm{PID}}\mathbf{I} \quad \mathbf{0} \\ * \quad * \quad * \quad -\gamma_{\mathrm{PID}}\mathbf{I} \end{bmatrix} < 0$$
(A6)

where

$$\tilde{\Gamma} = \begin{bmatrix} \tilde{A}P_{11} + \tilde{B}[\hat{k}_{d}(C\mathbf{I} - A_{m}) - \hat{k}_{p}C]P_{11} + \tilde{B}\hat{k}_{i}P_{12}^{T} & \tilde{A}P_{12} + \tilde{B}[\hat{k}_{d}(C\mathbf{I} - A_{m}) - \hat{k}_{p}C]P_{12} + \tilde{B}\hat{k}_{i}P_{22} \\ -CP_{11} + P_{12}^{T} & -CP_{12} + P_{22} \end{bmatrix}$$
(A7)

Note that $\tilde{\Gamma}$ can be reformulated as

$$\tilde{\Gamma} = \Gamma + \Phi_{A1}\tilde{\Theta}_{1}(t)\Phi_{A2} + \Phi_{B1}\tilde{\Theta}_{2}(t)\Phi_{B2}$$
(A8)

where Γ , Φ_{A1} , Φ_{A2} , Φ_{B1} , and Φ_{B2} have been shown in (22), $\mathbf{R}_1 = [\hat{\mathbf{k}}_d(\mathbf{CI} - \mathbf{A}_m) - \hat{\mathbf{k}}_p \mathbf{C}]\mathbf{P}_{11} + \hat{\mathbf{k}}_i \mathbf{P}_{12}^T$ and $\mathbf{R}_2 = [\hat{\mathbf{k}}_d(\mathbf{CI} - \mathbf{A}_m) - \hat{\mathbf{k}}_p \mathbf{C}]\mathbf{P}_{12} + \hat{\mathbf{k}}_i \mathbf{P}_{22}$.

The following lemma is used herein for analysis.

Lemma 2 [34]: Let A, D, E, and F be real matrices of appropriate dimensions with $\|F\| \le 1$, the following inequality holds for any scalar $\varepsilon > 0$,

$$DFE + E^{T}F^{T}D^{T} < \varepsilon DD^{T} + \varepsilon^{-1}E^{T}E$$
(A9)

Using Lemma 2 and the Schur complement, it can be seen that (A6) is guaranteed by (22) in Theorem 1. This completes the proof. \Box

Appendix II

Proof of Theorem 2

The robust 2D control objective in (38) can be rewritten as

$$J_{BP} = \sum_{t=0}^{N_{I}=T_{p}} \sum_{k=0}^{N_{2}\to\infty} (\gamma_{ILC}^{-1} \| \zeta(t,k+1) \|_{2}^{2} - \gamma_{ILC} \| \varpi(t,k+1) \|_{2}^{2} + \Delta V) - \sum_{t=0}^{N_{I}=T_{p}} \sum_{k=0}^{N_{2}\to\infty} \Delta V < 0$$
(A10)

where ΔV is a Lyapunov-Krasovskii function used for analysis of 2D asymptotic stability, i.e.

$$\Delta \mathbf{V} = \mathbf{V}_{\mathbf{Q}} \begin{bmatrix} \mathbf{x}^{\mathrm{h}}(t+1,k) \\ \mathbf{x}^{\mathrm{v}}(t,k+1) \end{bmatrix} - \mathbf{V}_{\mathbf{Q}} \begin{bmatrix} \mathbf{x}^{\mathrm{h}}(t,k) \\ \mathbf{x}^{\mathrm{v}}(t,k) \end{bmatrix}$$
(A11)

Using the boundary conditions from an initial resetting of batch process operation, i.e.

$$\begin{cases} \delta \mathbf{x}(0,0) = \delta \mathbf{x}(0,1) = \delta \mathbf{x}(1,0) = 0; \\ \delta \mathbf{e}_{s}(0,0) = \delta \mathbf{e}_{s}(0,1) = \delta \mathbf{e}_{s}(1,0) = 0; \\ \delta \sum \mathbf{e}_{s}(0,0) = \delta \sum \mathbf{e}_{s}(0,1) = \delta \sum \mathbf{e}_{s}(1,0) = 0; \\ \mathbf{e}(0,0) = \mathbf{e}(0,1) = \mathbf{e}(1,0) = 0. \end{cases}$$
(A12)

it can be easily verified using $Q = diag\{Q_1, Q_2, Q_3, Q_4\}$ that

$$\begin{split} \sum_{t=0}^{N_1=T_p} \sum_{k=0}^{N_2 \to \infty} \Delta V &= \sum_{t=0}^{N_1=T_p} \sum_{k=0}^{N_2 \to \infty} \left\{ V_{Q_1} [\delta x(t+1,k+1)] - V_{Q_1} [\delta x(t,k+1)] + V_{Q_2} [\delta e_s(t,k+1)] - V_{Q_2} [\delta e_s(t,k+1)] - V_{Q_2} [\delta e_s(t-1,k+1)] + V_{Q_2} [\delta (t+1,k+1)] - V_{Q_2} [\delta$$

$$= \sum_{k=0}^{N_2 \to \infty} V_{Q_1} [\delta x(N_1 + 1, k + 1)] + \sum_{k=0}^{N_2 \to \infty} V_{Q_2} [\delta e_s(N_1, k + 1)] \\ + \sum_{k=0}^{N_2 \to \infty} V_{Q_3} [\delta \sum e_s(N_1, k + 1)] + \sum_{t=0}^{N_1} V_{Q_4} [e(t + 1, N_2 + 1)] \\ > 0$$
(A13)

Therefore, a sufficient condition to ensure the control objective in (A10) is that

$$\gamma_{\rm ILC}^{-1} \left\| \zeta(t,k+1) \right\|_2^2 - \gamma_{\rm ILC} \left\| \varpi(t,k+1) \right\|_2^2 + \Delta V < 0 \tag{A14}$$

By substituting the 2D system description in (37) and (A11) into (A14), we obtain

$$\boldsymbol{\xi}^{\mathrm{T}}\boldsymbol{\Xi}_{2}\boldsymbol{\xi}<\boldsymbol{0}\tag{A15}$$

(A16)

where $\boldsymbol{\xi} = \begin{bmatrix} [\mathbf{x}^{h}(\mathbf{t},\mathbf{k})]^{T}, [\mathbf{x}^{v}(\mathbf{t},\mathbf{k})]^{T}, \boldsymbol{\varpi}^{T}(\mathbf{t}) \end{bmatrix}^{T}$, and $\boldsymbol{\Xi}_{2} = \begin{bmatrix} \tilde{\Psi}^{T} \\ \mathbf{D}_{w}^{T} \end{bmatrix} \mathbf{Q} \begin{bmatrix} \tilde{\Psi} & \mathbf{D}_{w} \end{bmatrix} - \begin{bmatrix} \mathbf{Q} - \boldsymbol{\gamma}_{\text{ILC}}^{-1} \mathbf{G}^{T} \mathbf{G} & \mathbf{0} \\ * & \boldsymbol{\gamma}_{\text{ILC}} \mathbf{I} \end{bmatrix}$

By the Schur complement, it can be derived that (A15) is guaranteed by

$$\begin{bmatrix} -\mathbf{Q} & \tilde{\Pi} & \mathbf{D}_{w} & \mathbf{0} \\ * & -\mathbf{Q} & \mathbf{0} & \mathbf{Q}\mathbf{G}^{\mathrm{T}} \\ * & * & -\gamma_{\mathrm{HC}}\mathbf{I} & \mathbf{0} \\ * & * & * & -\gamma_{\mathrm{HC}}\mathbf{I} \end{bmatrix} < 0$$
(A17)

where

$$\tilde{\Pi} = \Pi + \Omega_{A1} \tilde{\Theta}_1(t) \Omega_{A2} + \Omega_{B1} \tilde{\Theta}_2(t) \Omega_{B2}$$
(A18)

where Π , Ω_{A1} , Ω_{A2} , Ω_{B1} , and Ω_{B2} have been shown in (40).

Using Lemma 2 in Appendix I and the Schur complement, it can be seen that (A17) is guaranteed by (40) in Theorem 2. This completes the proof. \Box

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List of Figure Captions

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Figure 1 Block diagram of the proposed PID based indirect-type ILC scheme



Figure 2 Tracking performance for case 1



Figure 3 Plot of ATE for case 1



Figure 4 Plot of ATE for case 2